03500.109594.

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	
DAISUKE MIURA, et al.		;	Examiner: Julio J. Maldonado
Application No.: 10/555,614		: )	Group Art Unit: 2823
371(c) Date: November 4, 2005		)	
For:	FIELD EFFECT TRANSISTOR, METHOD OF PRODUCING THE SAME, AND METHOD OF PRODUCING LAMINATED MEMBER	; ; ; ;	November 10, 2008

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

OK TO ENTER: /J.M./ AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated September 3, 2008, please amend the above-identified application, as follows: